

Form PTO-1449  
(Rev. 8-83)U.S. Department of Commerce  
Patent and Trademark Office

Attorney Docket No. 0756-1974

Serial No. Not Yet Assigned

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Yasuhiko TAKEMURA et al.

Filing Date: May 27, 1999

Gr up: 2822

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
m	5,488,001	1/1996	Brotherton			
	5,346,839	9/1994	Sundaresan			
	4,649,626	3/1987	Leong			
	5,773,330	6/1998	Park	438	164	
	5,726,082	3/1998	Park et al.	438	165	
	4,425,700	1/17/84	Sasaki et al.	257	354	
	4,523,963	6/18/85	Ohta et al.	257	354	
	5,212,397	5/18/93	See et al.	257	354	
	5,275,851	1/1994	Fonash et al.			
	5,130,264	7/1992	Troxell et al.			
	4,523,963	6/1985	Ohta et al.			
	4,277,883	7/1981	Kaplan			
m	5,403,772	4/1995	Zhang et al.			

## FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation Yes No	
m	57-208124	12/21/82	Japan			Abstract	
	61-251166	11/8/86	Japan			Abstract	
	02-014579	1/18/90	Japan			Abstract	
	03-203378	9/5/91	Japan			Abstract	
	62-219961	9/28/87	Japan			Abstract	
	63-110667	5/16/88	Japan			Abstract	
	62-145775	6/29/87	Japan			Abstract	
	63-058875	3/14/88	Japan			Abstract	
m	02-140915	5/30/90	Japan			X	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

m		"Ultra LSI Process Data Hand Book", Scienc Forum Co., April 15, 1982, pp. 124-131.
m		Ito et al., "Thin Film Technique for VLSI" Maruzen Co., September 30, 1986, pp. 19-20.
Examiner	<del>Yung A. Lin</del> Yung A. Lin	Dat Considered 12-21-99